Electronic Patent A	\pp	lication Fee	Transm	ittal		
Application Number:	10524525					
Filing Date:	18-Aug-2005					
Title of Invention:	Method for selectively removing material from the surface of a substrate, masking material for a wafer, and wafer with masking material					
First Named Inventor/Applicant Name:	Martin Hausner					
Filer:	David H. Brinkman/Rhonda Etienne					
Attorney Docket Number:	BE	ET-09				
Filed as Large Entity						
U.S. National Stage under 35 USC 371 Filing	Fee	s				
Description		Fee Code	Quantity	Amount	Sub-Total in USD(\$)	
Basic Filing:						
Pages:						
Claims:						
Miscellaneous-Filing:						
Petition:						
Patent-Appeals-and-Interference:						
Post-Allowance-and-Post-Issuance:						
Extension-of-Time:						
Extension - 3 months with \$0 paid		1253	1	1110	1110	

Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
Miscellaneous:				
	Total in USD (\$)			1110